

102813261

Atty Docket No: 0553-0420

In re application of: Kunihiko FUKUCHI Serial No: Filed: Herewith For: Method For Manufacturing Wiring And Method For Manufacturing Semiconductodapesites) with the United States Postal Service Express Mail Post Office to Addressee service under 37 CFR1.10 on the date indicated above and is addressed to: Commissioner for Patents, PATENT ASSIGNMENT COVER SHEET PATENT ASSIGNMENT COVER SHEET Name: PATENT ASSIGNMENT COVER SHEET Name: Your Manufacturing Semiconductodapesites) with the United States Postal Service under 37 CFR1.10 on the date indicated above and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 (typed or printed) Signature Signature	IN THE UNITED STATES PAT	EXPRESS Mail Mailing Label No. EV 459448850
Concerning Document Should be Mailed: 2a. Name and Address of Receiving Party(ies): Name: Semiconductor Energy Laboratory Co., Ltd. Address: 398, Hase, Atsugi-shi, Kanagawa-ken 243-0036 Japan 2b. Name and Address of Receiving Party(ies): Name: Address Address Address 2a. Name and Address of Receiving Party(ies): Name: 243-0036 Japan 2b. Name and Address of Receiving Party(ies): Name: Address Address 2d. OOK, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 Cook, ALEX, McFARRON, MANZO, CUMMINGS & AMEILER, LTD. Cook, ALEX, McFARRON, ManZO, CUMMINGS & AMEILER, LTD. Cook, ALEX, McFARRON, ManZO, CUMMINGS & AMEILER, LTD. Cook adams Street, Suite 2850 Chicago, Illinois 60606 Cook adams Street, Suite 2850 Cook adams Street, Suite 2850 Cook adams Street, Suite 2850 Cook adams Str	In re application of: Kunihiko FUKUCHI Serial No: Filed: Herewith For: Method For Manufacturing Wiring And Method For Manu Art Unit: Examiner: PATENT ASSIGNM Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 Sir:	Date of Deposit August 5, 2004 I hereby certify that this correspondence is being facturing Semiconductodeposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR1.10 on the date indicated above and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 Name: Yellow August 3, 2004 (typed or printed) Signature
	 Kunihiko FUKUCHI 2a. Name and Address of Receiving Party(ies): Name: Semiconductor Energy Laboratory Co., Ltd. Address: 398, Hase, Atsugi-shi, Kanagawa-ken 243-0036 Japan 2b. Name and Address of Receiving Party(ies): Name: Address	Concerning Document Should be Mailed: Edward D. Manzo, Esq. COOK, ALEX, McFARRON, MANZO, CUMMINGS & MEHLER, LTD. 200 West Adams Street, Suite 2850 Chicago, Illinois 60606 6. Total Number of Applications and Patents Involved: 1 7. Total Fee (37 CFR 3.41): \$40.00 7a. X Enclosed 7b. X Authorized to be Charged to Deposit Account For Any Deficiency 8. Deposit Account Number: 50/1039 (A duplicate copy of this page is attached) 9. Statement and Signature: To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document. Mark J. Murphy Name of Person Signing Signature Reg. No. 34,225
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PATENT REEL: 015668 FRAME: 0465

Attorney Docket	
ASSIGNMENT	
Identity Of The Patent Application. I am the inventor (or one joint inventor) of a patent application that I am assigning. The patent application I am assigning is entitled METHOD FOR MANUFACTURING WIRING AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE which I executed herewith. If the patent application has already been filed, it received serial number and bears a filing date of	
The Assignee and The Assignment. I assign my patent rights to Semiconductor Energy Laboratory Co., Ltd., a corporation organized according to the laws of Japan, having a place of business at 398, Hase, Atsugi-shi, Kanagawa-ken 243-0036 Japan (hereinafter "the Assignee"). The rights I assign are my entire right, title and interest in the invention or improvements disclosed in the patent application and any and all other applications for United States Letters Patent which I may file, either solely or jointly with others, on the invention or improvements, including all continuations, divisionals, and continuations-in-part, and in any and all United States Letters Patent which may be obtained on any of said applications, and in any reissue or extension thereof. I also assign to the Assignee all priority rights under the International Convention. I agree to execute, at the request of the Assignee, all documents in connection with any application for United States letters patent therefor.	
Payment Received. I am making this assignment in consideration of One Dollar and other good and valuable consideration. I acknowledge the receipt and sufficiency of the consideration.	
Authorizations. I request the U.S. Commissioner of Patents and Trademarks to issue the Letters Patent to the Assignee. I authorize the attorney(s) of record in the application to insert in this assignment document the date and serial number of the application.	
Further Acts. I agree, upon the request and at the expense of the Assignee, to execute any divisional, continuation or substitute application for the invention or improvements, and any oath, declaration or affidavit relating thereto, and any application for the reissue or extension of any Letters Patent that may be granted upon the application. I agree to perform, upon request, any affirmative acts to obtain said Letters Patent of the United States and to vest in the Assignee all rights therein, so that the Letters Patent will be held and enjoyed by the Assignee, to the full end of the term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me if this assignment had not been made.	
Interference. In the event that any application or Letters Patent that I now assign becomes involved in interference, I agree to cooperate to the best of my ability in the matters of preparing and executing the preliminary statement and giving and producing evidence in support thereof.	
Kunihiko Fukuchi 07/21/2004 Name: Kunihiko Fukuchi Date	
Name: Date	

Date

Date

RECORDED: 08/05/2004

Name:

Name:

PATENT REEL: 015668 FRAME: 0466